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520.37698CX1
Response Under 37 CFR 1.116
Expedited Procedure
Group No. 1763

AP 1700
#190NE
12/20/02
NW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: K. TAKAHASHI, et al.
Serial No.: 09/414,520
Filed: October 8, 1999
For: PLASMA PROCESSING APPARATUS AND A PLASMA
PROCESSING METHOD
Group: 1763
Examiner: R. Zervigon

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RESPONSE UNDER 37 CFR 1.116

ATTN: BOX AF
Commissioner for Patents
Washington, D.C. 20231

December 17, 2002

Sir:

The following is in response to the final Office Action of September 19, 2002:

REMARKS

In the Office Action of September 19, 2002, Claims 1, 2, 4 - 7, 9 and 10 were rejected. No claim was allowed. Reconsideration and reexamination are respectfully requested in view of the following remarks.